



Tool Make & Model

Tool Configuration / Specifications

COM-SU-2000
SU-2000
Single Wafer Cleaner

8 inch wafers configuration
system configured for SC1 / SC2 / dHF / dHCl
4 chambers
3 Load ports
Shield plate
Open cassette
BCR reader
EC 3 unit (Room temperature) and Heater for 2 chemical (65 degree)
HDIW unit (KELK)
Eflow cabinet
Safety manual in French language
CE marking

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